



Patent
Attorney's Docket No. 1003510-000161

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Tsutomu Saimoto et al.

Application No.: 10/506,806

Filed: September 7, 2004

For: PRESSURE SENSITIVE ADHESIVE
FILM FOR PROTECTION OF
SEMICONDUCTOR WAFER
SURFACE AND METHOD OF
PROTECTING SEMICONDUCTOR
WAFER WITH THE PRESSURE
SENSITIVE ADHESIVE FILM

) MAIL STOP AF

) Group Art Unit: 2811

) Examiner: Steven Ho Yin Loke

) Confirmation No.: 5415

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11/27/06*

AMENDMENT AND SUBMISSION OF TECHNICAL INFORMATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed August 9, 2006, please amend the above-identified application as follows: